

VLSI Test Technology and Reliability

Lecture 10(2)

Semiconductor Reliability

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Learning aims

- Realize the importance of reliability
- Describe reliability failure mechanisms
- How to measure reliability
- Future reliability challenges

Contents

- Concepts and definitions
- Motivations
- Semiconductor reliability
- Failure mechanisms
- Reliability testing
- Future challenges and summary

Concepts and definitions

Design,
manufacturing,
and test

Operational life

Wearout

Quality

- Guarantee that the IC performs its function at $t=0$
time-independent
- Driven by defect/fault during manufacturing

Reliability

- Guarantee that the IC performs its function for $0 \leq t \leq \text{lifetime}$
- Meeting specification over time
time-dependent
- Driven by changing material properties, application profile, environment.

Reliability moves farther than Quality

Motivations

➤ People Life

- Reliable products save people in
 - Highway travelling
 - Air travel
 - Life critical medical procedures

➤ Customer Satisfaction

- Reliability effects future business
 - Iphone satisfied 82% of users
 - 16% of them bought Iphone in next 6 months

➤ Competitiveness Advantage

- Reliable companies get greater market share
 - Apple got 20% additional market in US than Asus
 - Apple scored reliability 365 as compared to Asus 305

Motivation.....

- **Challenger (1986)**
 - Exploded after 73 seconds of liftoff
 - Failing of O-ring seal in solid rocket booster
- **Concord 4590 (2001)**
 - Reliability checks were ignored

The entire crew and passengers died

Customer satisfaction.....

- **Honda vs. Yogu**
- Yogu ignored reliability
 - The car is named Yugo, because it doesn't....
- **Toyota downfall 2010**
 - Ignored reliability of the break pedals
 - Lost 2 billion dollars

Business is lost

Competitiveness advantage...

~~Reliability~~

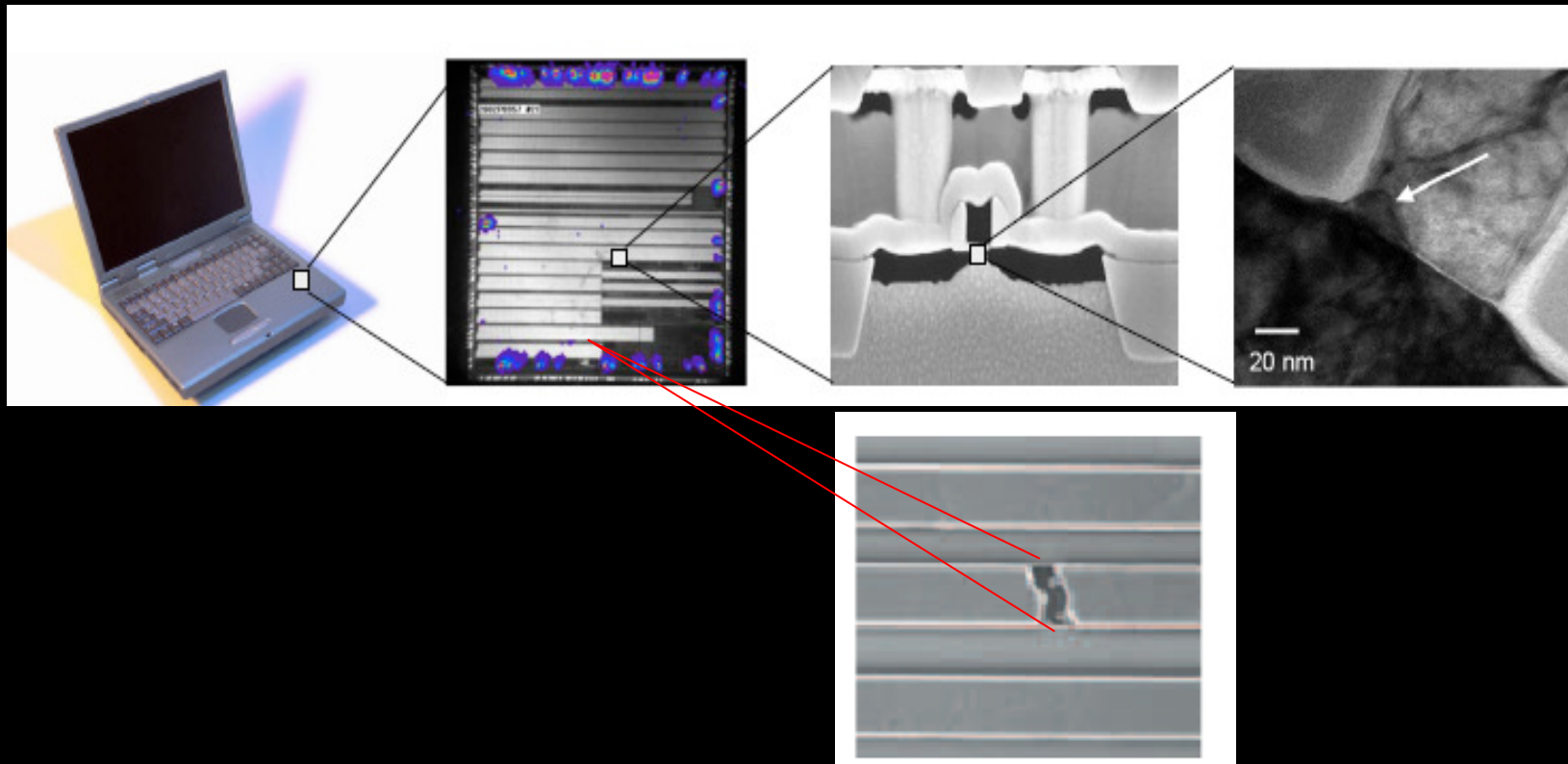
- **Intel's 820 Chipset Delayed**
 - Focused on design but avoided reliability analysis
 - Officials reported that delay is due to reliability issues in 820 chipset



First to enter market, first to leave

Semiconductor reliability

- IC turns on trillion of times in harsh condition during lifetime
- A manufacture bits the company on reliability physics



Semiconductor reliability..... Failures

➤ Reliability failure results in

- Functional failure

 - Permanent

 - Temporary

- Structural damage

➤ Failure sources

- Semiconductor doping

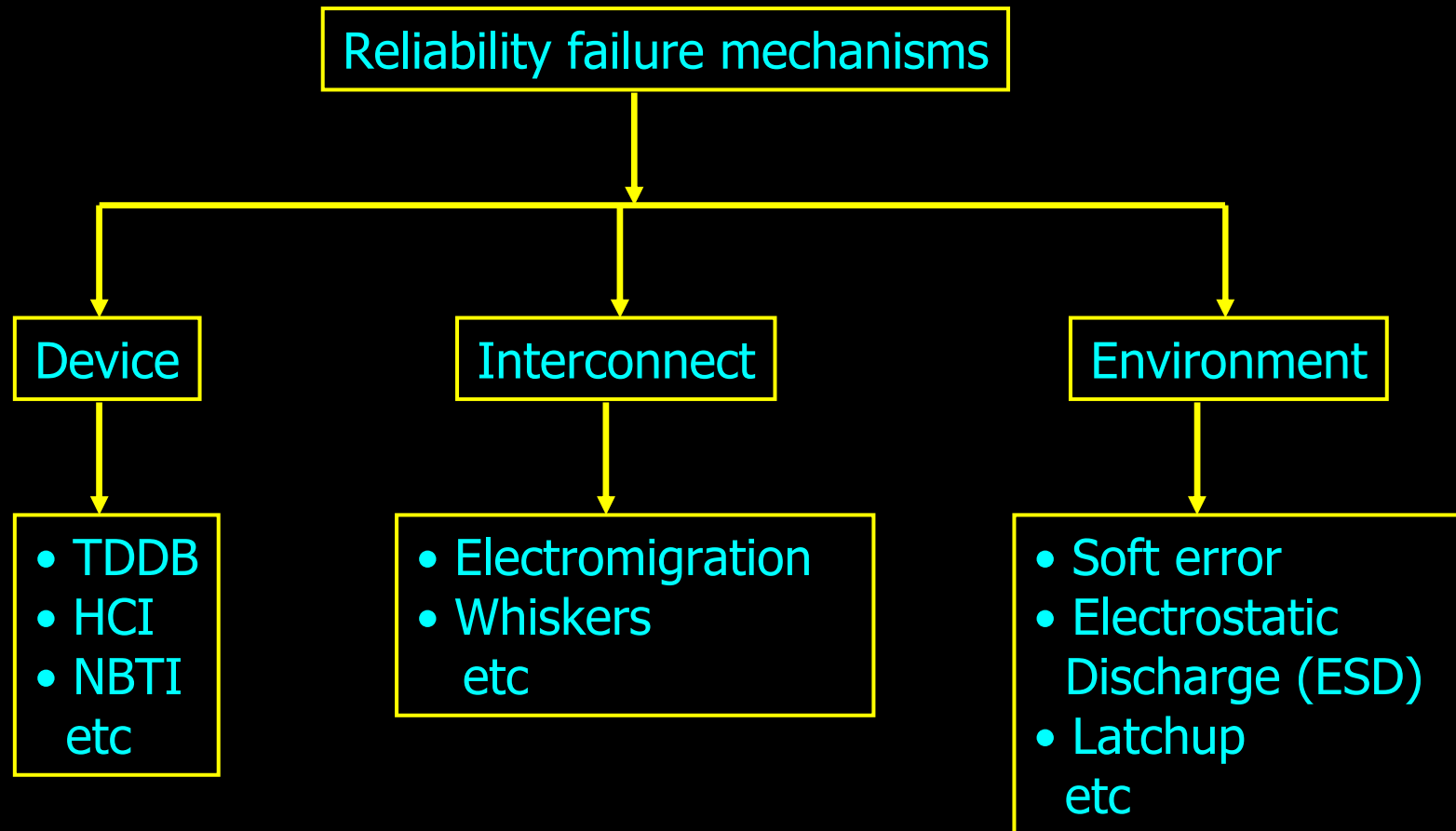
- Temperature

- Radiation

- Electric field

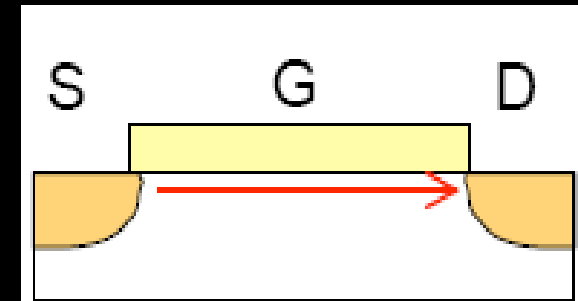
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Reliability failure mechanisms... Classification

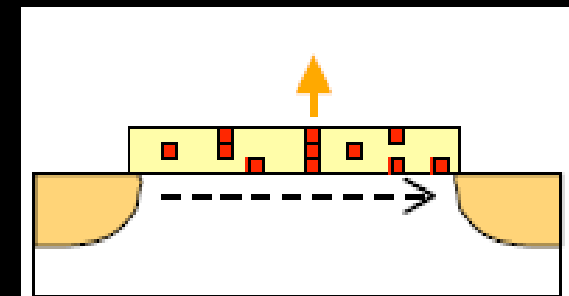


Device failure mechanisms

- Gate oxide degrade with the passage of time due to breaking of bonds
- **Broken Si-H bonds**
 - **PMOS:**
 - Negative Bias Temperature Instability (NBTI)
 - **NMOS:**
 - Hot carrier degradation (HCI)
- **Broken Si-O bonds**
 - Time Dependent Dielectric Breakdown (TDDB)



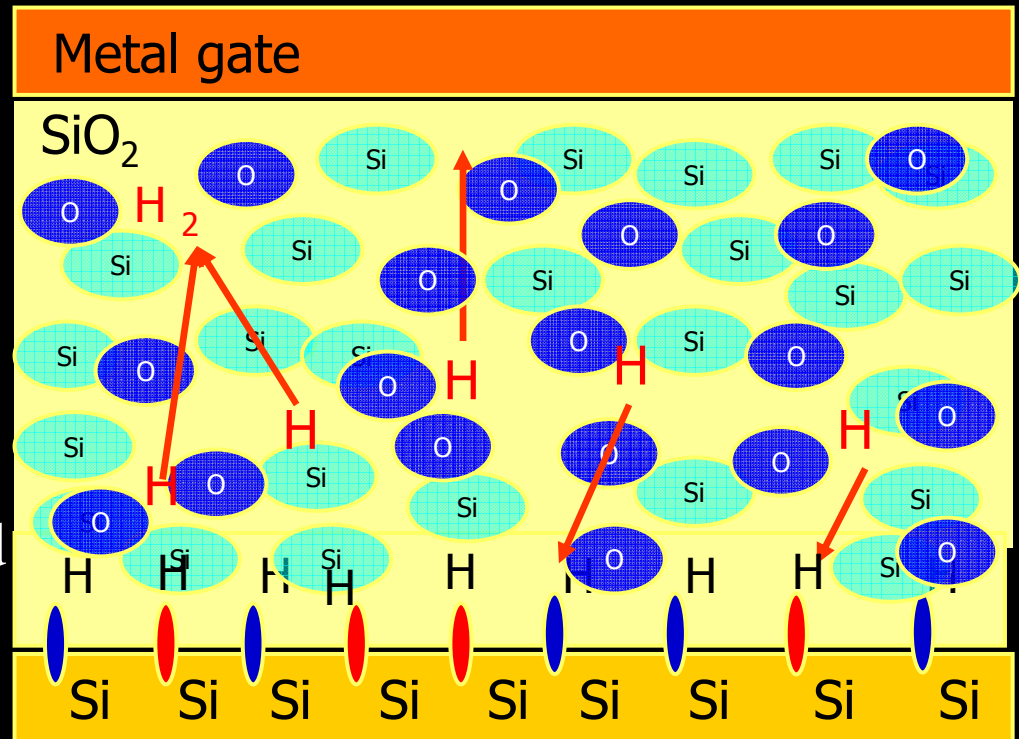
Initially



After some time

Device failures NBTI

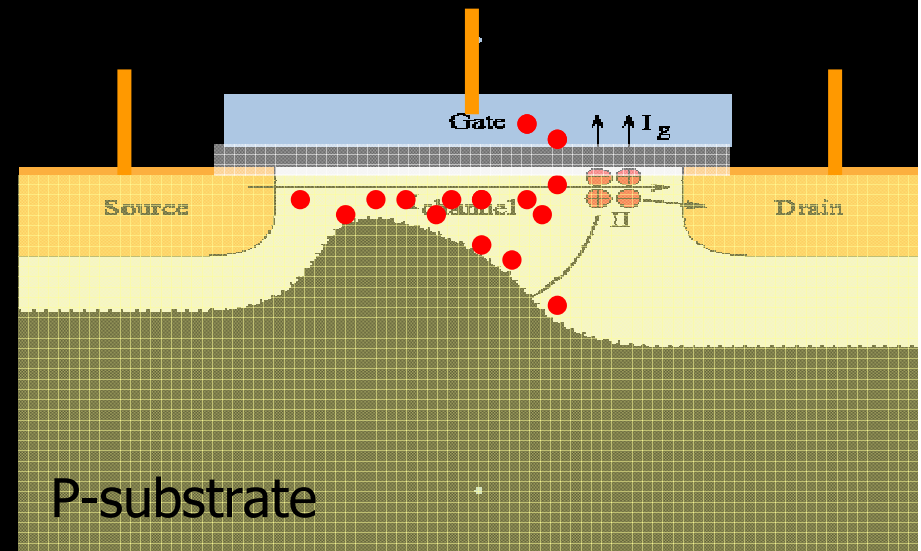
- NBTI degrades **PMOS transistor** at
 - Negative gate potential
 - Elevated temperature
- The gate potential breaks Si-H bonds and create positive charges at the interface
- The charges effect the threshold voltage, disrupting device characteristics
- Self annealing
- **After-effects**
 - **Threshold voltage increases**
 - **Drain current decreases**



High Electric field and Temperature enhances NBTI

Device failures HCI

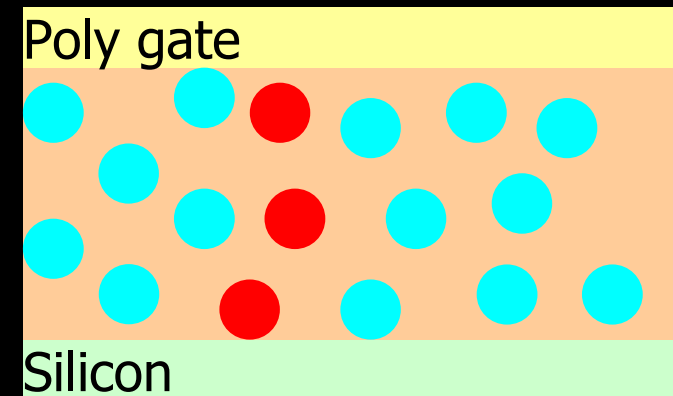
- HCI affects **NMOS transistor**
- Channel carriers get energy by impact ionization
- Most of the carriers are collected at the drains, but some are directed toward gate or substrate
- Energetic carriers breaks bonds in
 - Gate oxide
 - Silicon substrate
- **After-effects**
 - **Threshold voltage increases**
 - **Saturation current decreases**
 - **Leakage current increases**



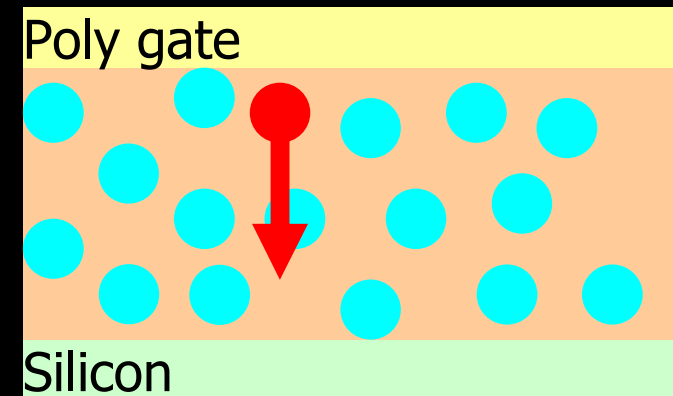
High carrier velocities and short channel enhances HCI

Device failures TDDB

- TDDB affects both **PMOS** and **NMOS** transistors
- Gate dielectric suffers from short circuit
- Percolation current
 - With the passage of time charges inside gate oxide align and result in a continuous path
- Direct tunnelling
 - Charges jumps directly across the oxide layer
- **After-effects**
 - **Loss of gate voltage control**
 - **Increase in gate current**



Percolation current



Direct tunneling

High temperature, thin oxides and high field enhances TDDB

Interconnect failures..... Electromigration (EM)

➤ EM affects **interconnects and bondings**

➤ Interconnect atoms migrate with electrons due to

➤ Field force

➤ Momentum exchange

➤ **After-effects**

➤ **Void formation**

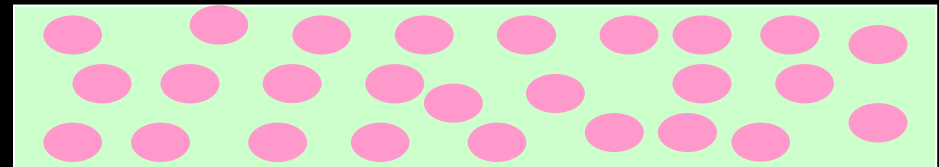
➤ **High resistance**

➤ **Open circuits**

➤ **Deposition**

➤ **Small resistance**

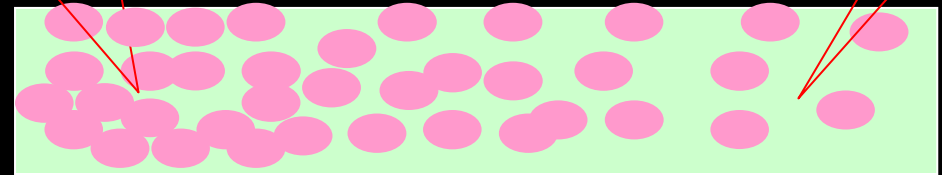
➤ **Short circuits**



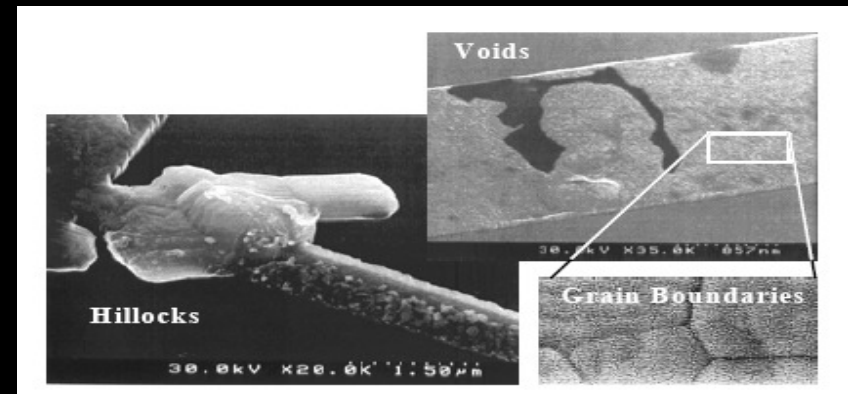
Deposition

initially

Void



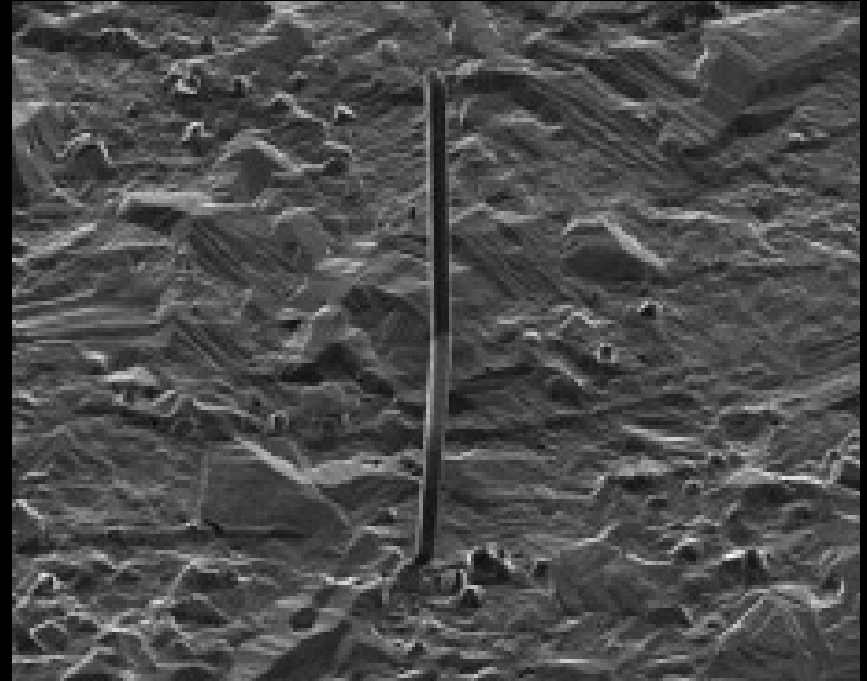
After some time



EM accelerates with shrinking interconnects and current density

Interconnect failures..... Whiskers

- Whiskers affects **interconnect joints**
- Needle like protrusion at joint that result from
 - Diffusion effect
 - Re-crystallization
- **After-effects**
 - **Electrical shorts**
 - **Antenna in high frequency applications**

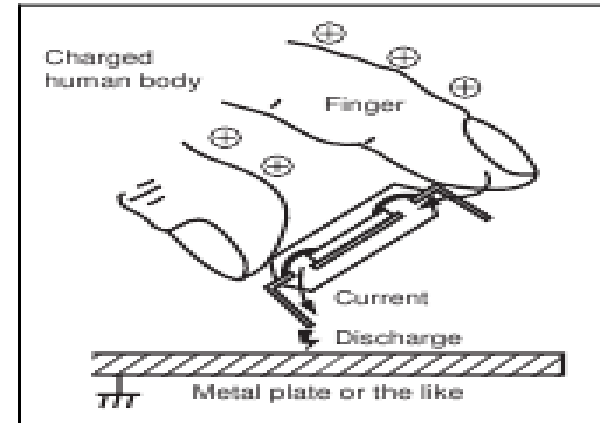


A thin whisker about 300nm long

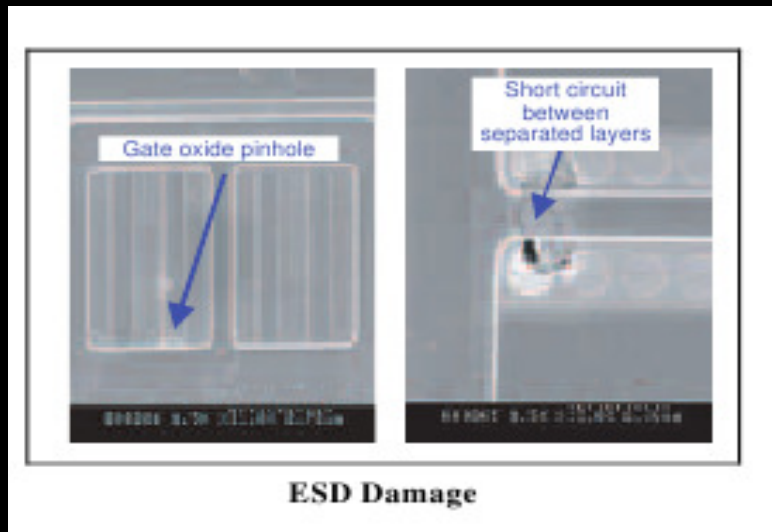
Whisker growth will accelerate due to ban on using lead (Pb)

Environmental failures.....ESD

- ESD is common phenomena observed by rubbing two object that creates charges
- ESD damages **gate oxide** due to
 - Static charges.
 - Switching transient
 - EM pulses
- Sources of charges
 - Human body
 - Manufacturing machines
 - Charged devices
- **After-effects**
 - Transistor junctions burnout
 - Metallization burnout



Discharge Model with Human Body

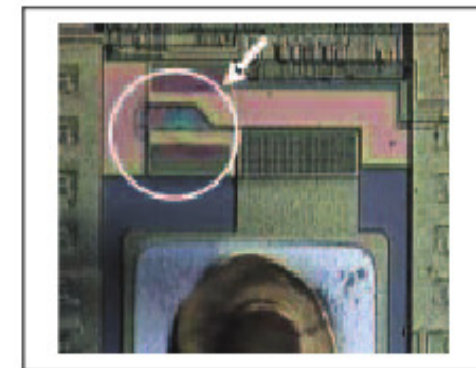
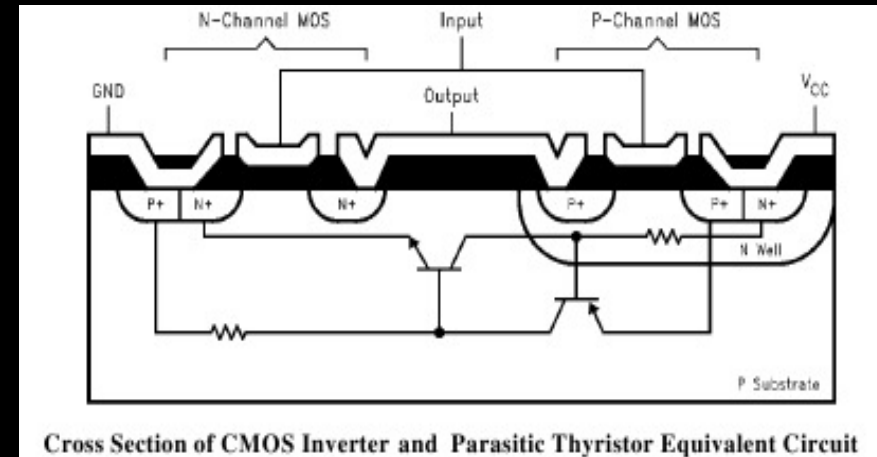


ESD Damage

ESD accelerates with scaling coz sources are constant

Latchup

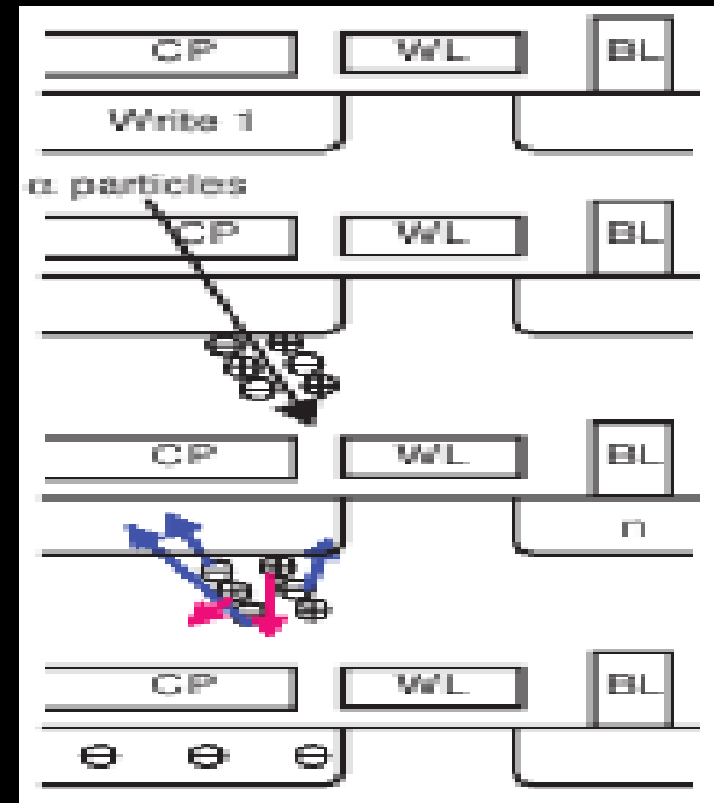
- Latchup affects both **PMOS** and **NMOS**
- Latchup ignites parasitic BJT's in CMOS due to
 - Supply voltage over/undershoot
 - External charges
- The cross coupled BJTs have positive feedback that shorts the internal CMOS junctions
- **After-effects**
 - Excessive drive currents
 - Function failure
 - Device burnout



Terminal Breakdown

Soft error

- Non-destructive change in **CMOS based storage devices**
- Ionization impacts a single/multiple cell/register/FF, causing change of state
- The change is
 - Random
 - Non recurring.
 - Single and multi-bit
- Sources of the damage are
 - Alpha particles
 - Neutrons
 - Radiations.



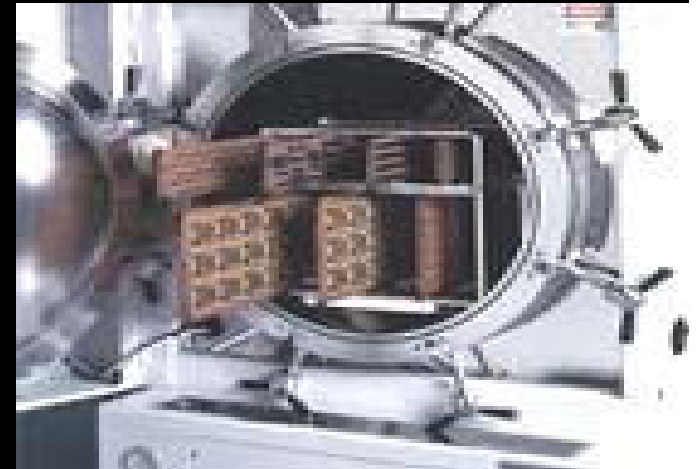
Becoming more severe with scaling, since **sources** do not scale

Reliability testing

- Reliability testing
 - In-house reliability testing
 - In-field reliability testing
- **In-house reliability testing**
 - A series of laboratory tests carried out under known stress conditions to evaluate the life span of a device
- **Well known reliability tests**
 - Burn-in
 - Early life burn in
 - High Temperature Operational Life (HTOL)
 - Highly Accelerated Stress Test (HAST)
 - Temperature cycle

In-house reliability testing..... Burn in

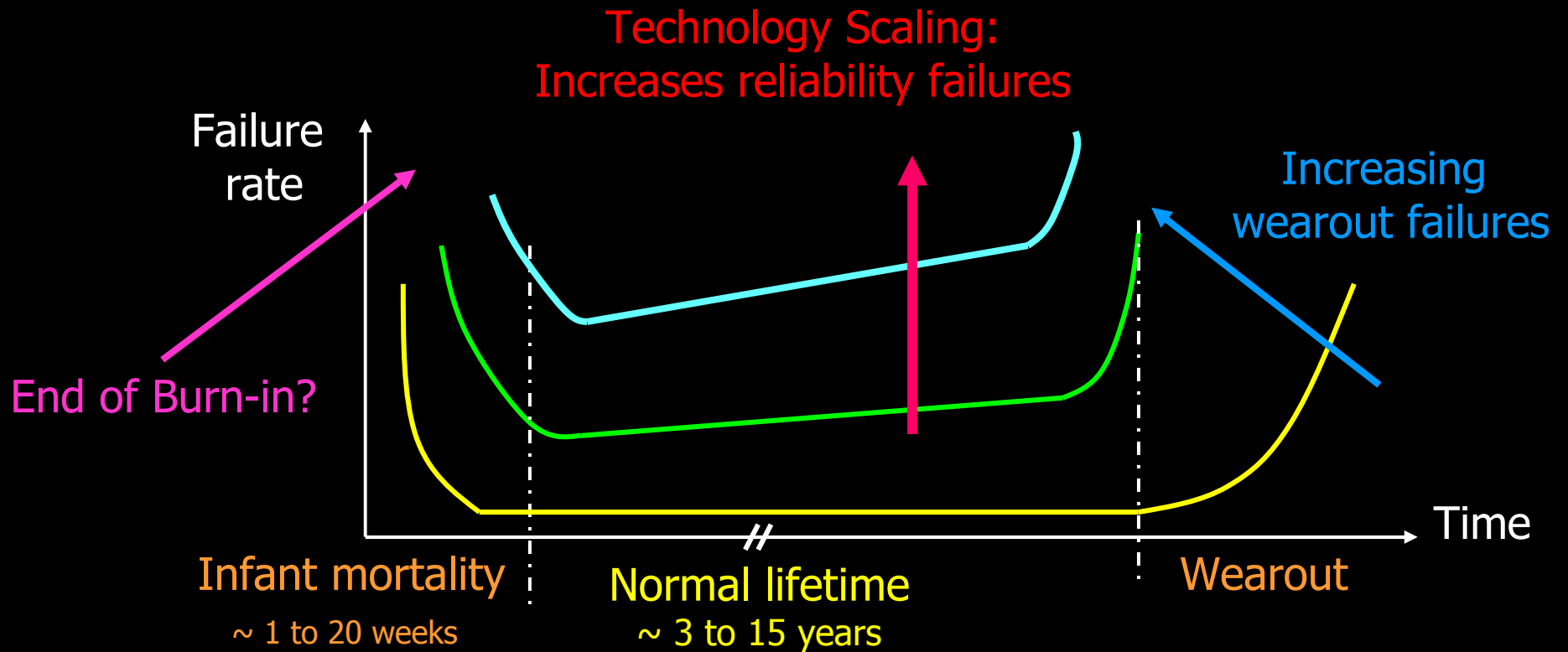
- **Early life burn-in** eliminates units with marginal defects
- Conditions
 - Temperature 125°C
 - **Time= 48-168 hours**
- **High Temperature Operational Life (HTOL)**
- HTOL determine high temperature lifetime of device under test
- Conditions
 - Temperature 125°C
 - **Time= 500-1000 hours**



In-house reliability testing..... HAST, TCT

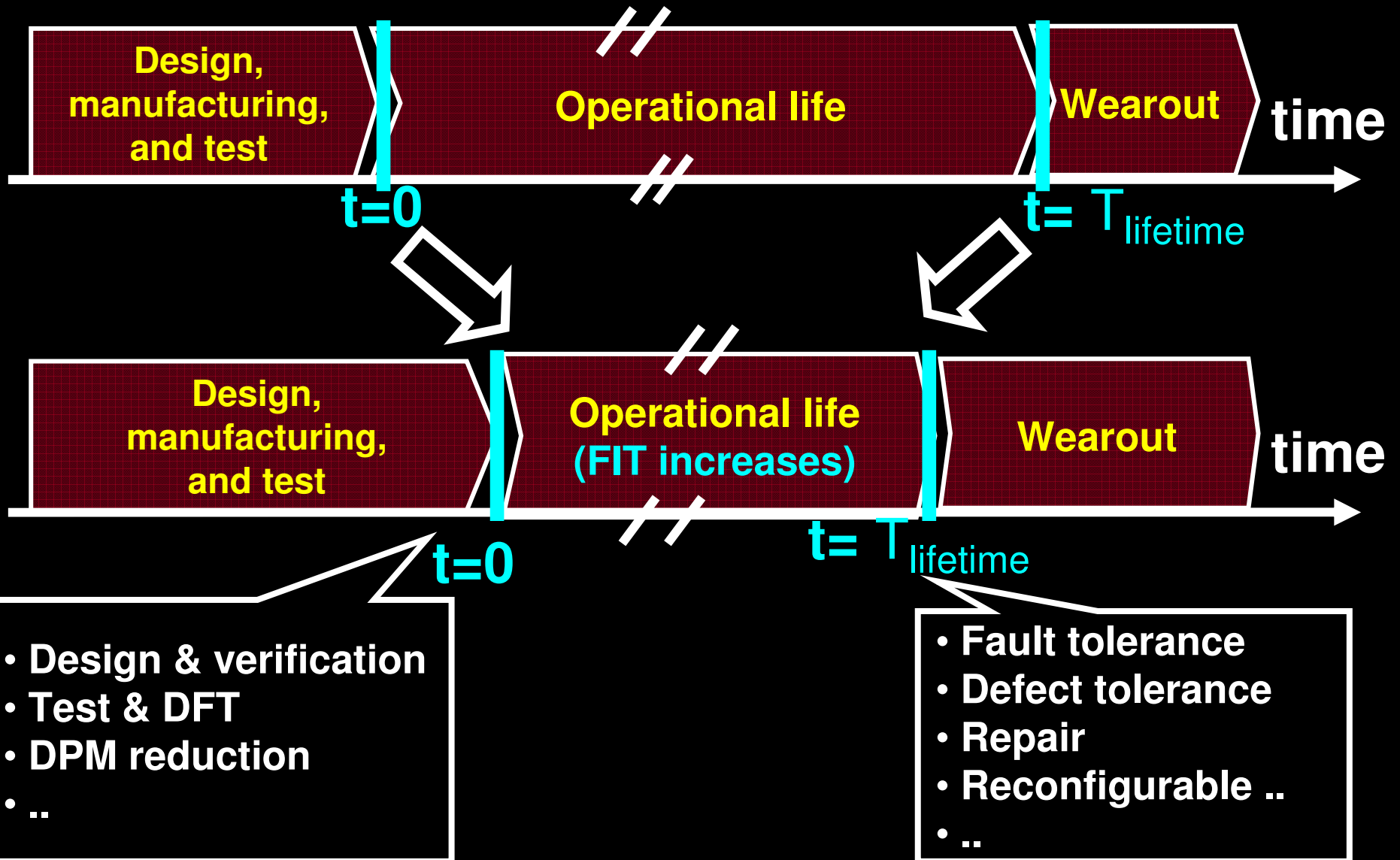
- **Highly Accelerated Stress Test (HAST)**
- Accelerate metal corrosion
- Conditions
 - Temperature 130°C
 - Relative humidity 85%
 - Time 96-100 hours
- **Temperature cycle test**
- To test for resistance at very high and very low temperature
- To test for cyclic stresses
- Conditions
 - Minimum of 10 cycles
 - -55°C to 85°C
 - -55°C to 125°C

Reliability testing Concerns

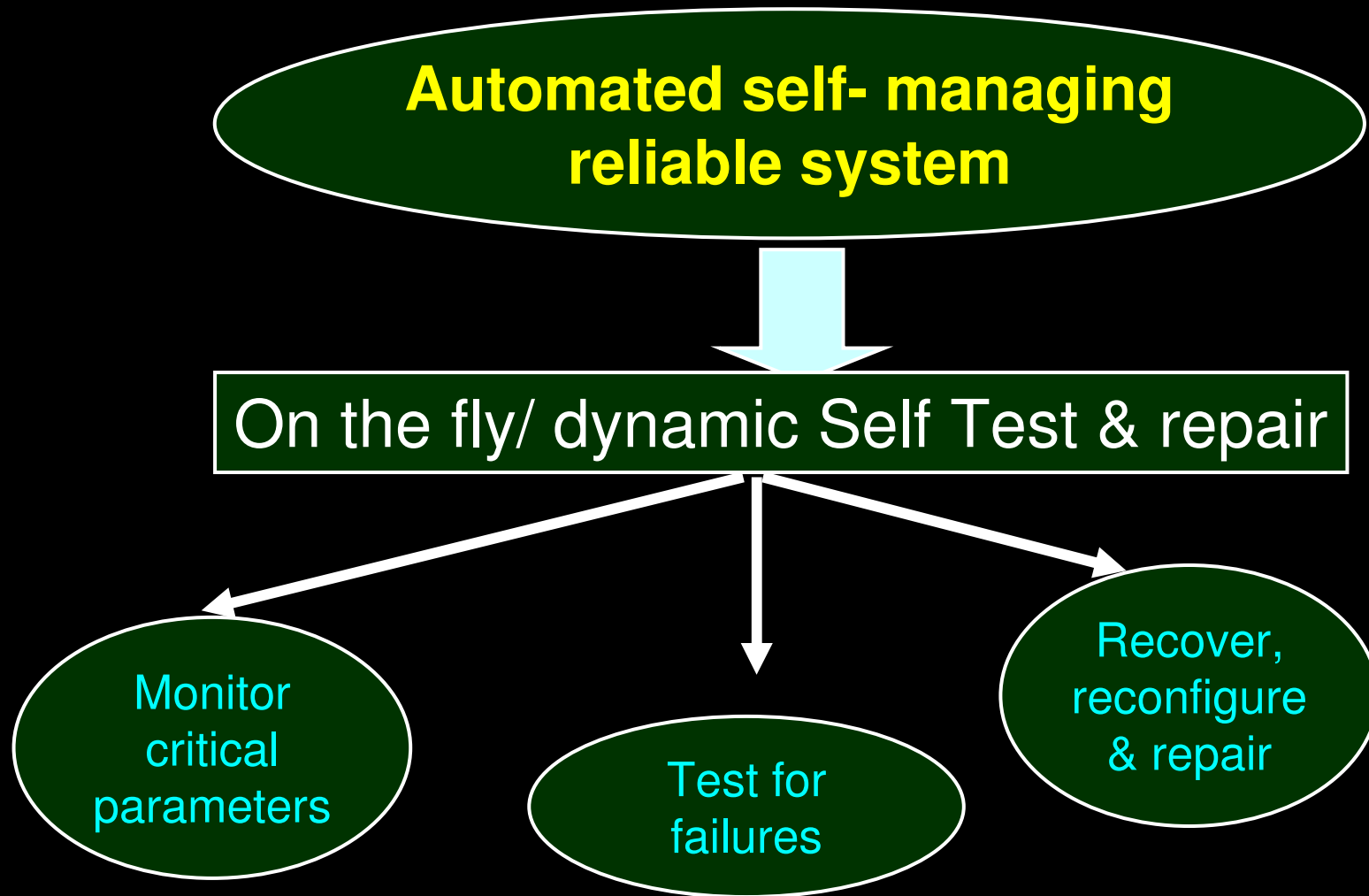


Shifting Bath tub curves limits benefits of in-house testing

Reliability testing.....



On Field Reliability testing and recovery



Future reliability challenges

- Ideal scaling law
 - 30% decrease in oxide thickness
 - 30% decrease in supply voltage
- Voltage cannot follow the scaling law
- The non-ideal scaling will **accelerate reliability failures**

- Smaller feature size
 - Narrow operation margin
 - Leakage current
 - Direct tunneling

- Thermal dissipation
 - Higher power density accelerate device failures
- New materials and **processes**
 - High-K dielectric
 - Carbon Nano Tubes (CNT)
 - 50 new processes per generation
- Device complexity

Conclusion

- Reliability is of main concern due to
 - People lives
 - Business survival
 - Larger profit margin
- Semiconductor reliability is more critical due
 - High complexity
 - Based on material physics
- Current reliability threats spans over
 - Transistors
 - Interconnects
 - Environment
- Reliability testing
 - In house testing
 - On field testing
- Reliability future is very challenging
 - High electric field
 - High complexity
 - New materials and processes